

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/811,107 Confirmation No. 9214
Applicant : Hironobu FUKUI
Filed : March 26, 2004
TC/A.U. : 2822
Examiner : LEWIS, Monica

Atty Docket No. : 351991-992050
Customer No. : 26379

Title: METAL OXIDE SEMICONDUCTOR (MOS) TYPE SEMICONDUCTOR
DEVICE AND MANUFACTURING METHOD THEREOF

AMENDMENT AND RESPONSE TO OFFICE ACTION

M/S: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action of August 24, 2007, please enter the amendments set forth below and consider the following remarks:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 5 of this paper.